

# Printed CulnSe<sub>2</sub> Nanocrystal Photovoltaic Devices

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# **Next Generation PV Devices**

- Solution processed
- Flexible and stretchable electronics
- Low cost, High efficiency

# CulnSe<sub>2</sub> (CIS)

 High efficiency & commercially viable
 No toxic elements like Cd or Pb
 × Require High Temperatures to form CIS (~550 °C)



CIS nanocrystals can solution processed at room temperature.



# **CulnSe<sub>2</sub> Nanocrystal Photovoltaics**

Mild Fabrication Processes

- Colloidal synthesis of chalcopyrite CuInSe<sub>2</sub> nanocrystals
- Solution processed inks
- Deposited in ambient conditions on substrates



Panthani et. al. J. Phys. Chem. Lett. 2013, 4, 2030.Panthani et. al J. Am. Chem. Soc., 2008, 130 (49), 16770 The efficiency of CIS nanocrystal PV is still not high (~3 %). We aim to investigate methods for improving the efficiency 3



# **CulnSe<sub>2</sub> Nanocrystal Photovoltaics**





# Intense Light Pulse Sintering

Requirements to minimize substrate heating

- Enable to remove ligands surround CIS
- Enable to sinter the CIS particles in the short time (~1 ms)



We can expect to improve CIS PV efficiency by intense light pulse

K. A. Schrode Mechanisms of Photonic Curing<sup>TM</sup>: Processing High Temperature Films on Low Temperature Substrates NCC NanoLLC 4



#### **Devices Made with "Pulse A-E"**

In this experiment we studied various light pulses. The temperature at the surface of the CIS layer was simulated.

| Pulse Name | Bank Voltage<br>(V) | Envelope Time<br>(µs) | Number of Pulses | Cycle Duty | Energy Input<br>(J/cm²) |
|------------|---------------------|-----------------------|------------------|------------|-------------------------|
| Pulse A    | 800                 | 700                   | 5                | 50%        | 3.848                   |
| Pulse B    | 700                 | 700                   | 5                | 50%        | 2.739                   |
| Pulse C    | 790                 | 150                   | 1                |            | 1.914 ± 0.032           |
| Pulse D    | 650                 | 600                   | 5                | 50%        | 1.958 ± 0.018           |
| Pulse E    | 500                 | 1200                  | 10               | 50%        | 1.925 ± 0.007           |





#### **Devices Made with "Pulse A-E"**

- Pulse A: Appears to short out the devices.
- Pulse B: Almost the same value as standard.
- Pulses C-E: Increasing the duration of pulses of the same energy improves performance.



High intensity Pulse (650-800 capacitor voltage) didn't give any improvement efficiency, likely due to thermal damage.



#### X-ray Photoelectron Spectroscopy (XPS)



Carbon layer on the pulsed CIS nanocrystal surface, likely reducing the efficiency of the CIS PV devices



# Raman Spectroscopy



- After Pulse, the CIS peak at 180 cm<sup>-1</sup> is stable.
  - → Pulse is useful for making a stable CIS crystal structure
- The peak coming from ligand or ordered defect compound (ODC) increased over laser exposure time.

   A Removing ligand and ODC will likely improve the efficiency.



### Raman Spectroscopy



• The peaks coming from ODC is stable over laser exposure time.

- We can see peak shift from 180-174 cm<sup>-1</sup> meaning cation ordering.
- → We can expect the higher efficiency of CIS nanocrystal PV devices baked and Pulsed.



# <u>Summary</u>

- ✓ High intensity Pulse (650-800 capacitor voltage) didn't give any improvement in efficiency like due to the carbon layer or defect formation
- ✓ We can expect that the efficiency of CIS PVs can be improved by baking in vacuum condition to remove some defects and ligands

#### **Future work**

- Prevent the formation of a carbon layer by baking in vacuum condition
- Fabrication and testing the baked and Pulsed CIS nanocrystal PVs devices



### **Acknowledgement**

#### Mentor: Dan Houck PI: Brian A. Korgel









National Nanotechnology Coordinated Infrastructure

